

# Timing performance of a digital SiPM prototype

## Studies with a fast injection laser

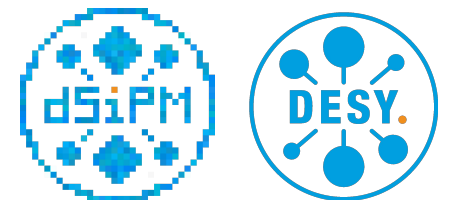
**Daniil Rastorguev** [daniil.rastorguev@desy.de](mailto:daniil.rastorguev@desy.de)

Inge Diehl, Karsten Hansen, Finn King, Stephan Lachnit, Frauke Poblitzki, Tomas Vanat, Gianpiero Vignola

PIXEL24

21.11.2024

HELMHOLTZ

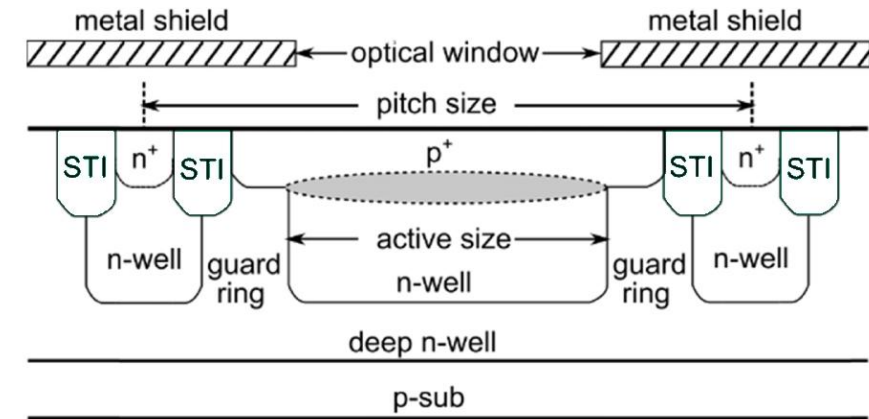


# dSiPM design overview

# SPADs meet CMOS

## The concept of a digital silicon photomultiplier

Schematic structure of a  $p^+$ /n-well SPAD in 150 nm CMOS [1] →



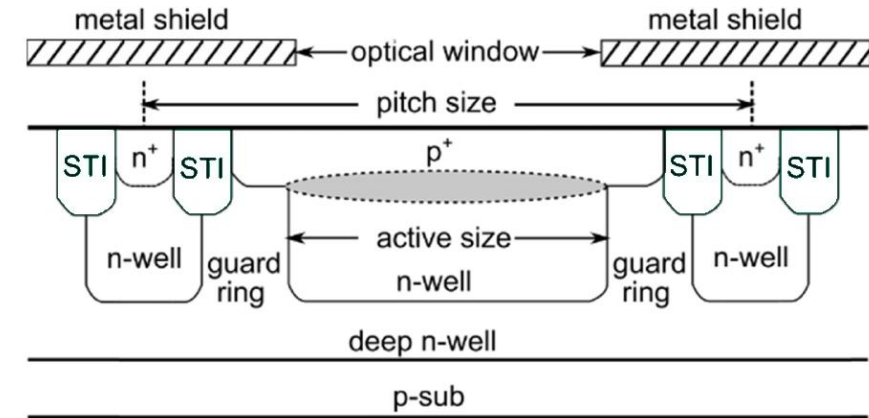
Specialty foundries  
now offer SPADs in  
their CMOS PDKs

Here: LFoundry 150 nm

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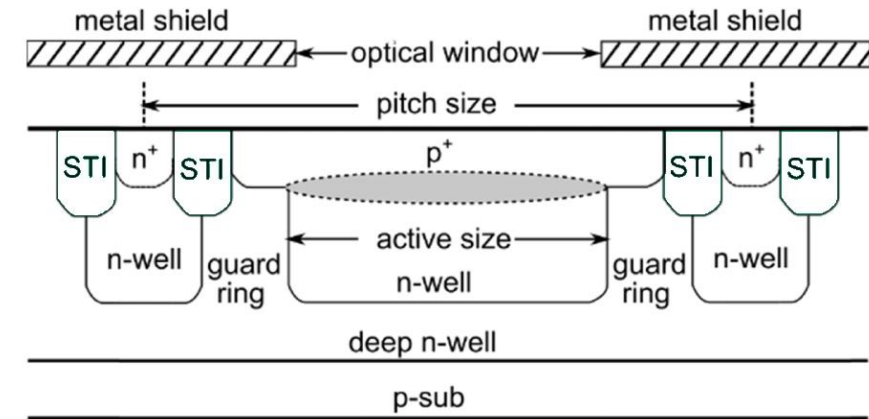
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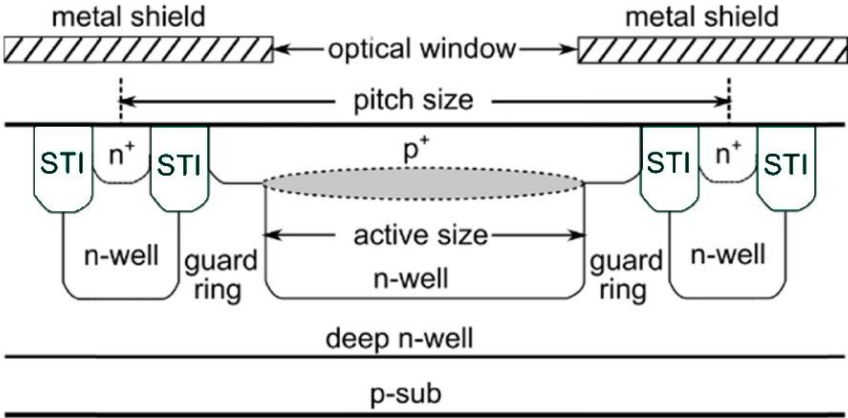


SiPM-like SPAD  
matrix

# SPADs meet CMOS

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<p>Specialty foundries now offer SPADs in their CMOS PDKs</p> <p>Here: LFoundry 150 nm</p>	<p>We designed a custom monolithic ASIC</p> 	<p>SiPM-like SPAD matrix</p> <p>Front-end and readout similar to pixel detectors</p>
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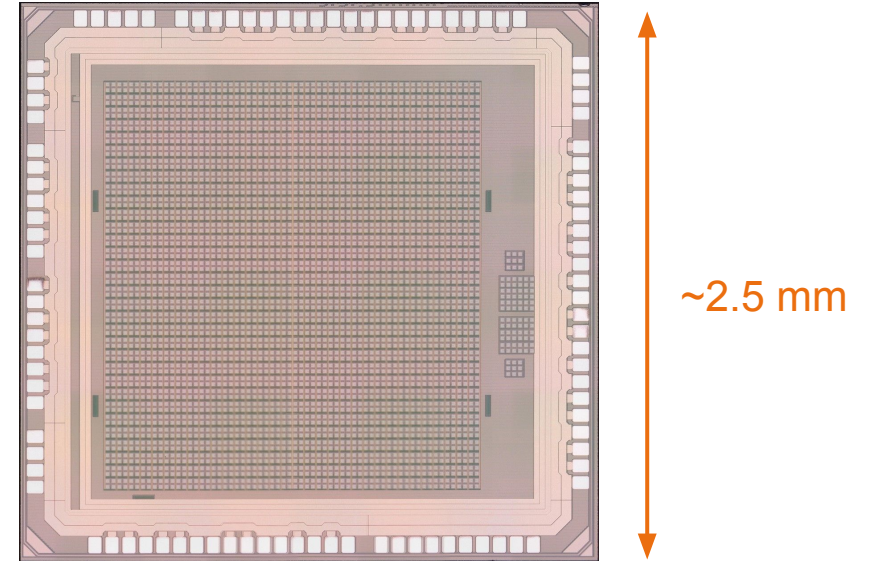
[1] [H. Xu et al. Optics Express 25\(11\) \(2017\) 12765-12778](#)

# DESY digital SiPM prototype

Designed in 150 nm LFoundry CMOS process

## Matrix:

- $32 \times 32$  pixels
- $70 \times 76 \mu\text{m}^2$  pixel pitch



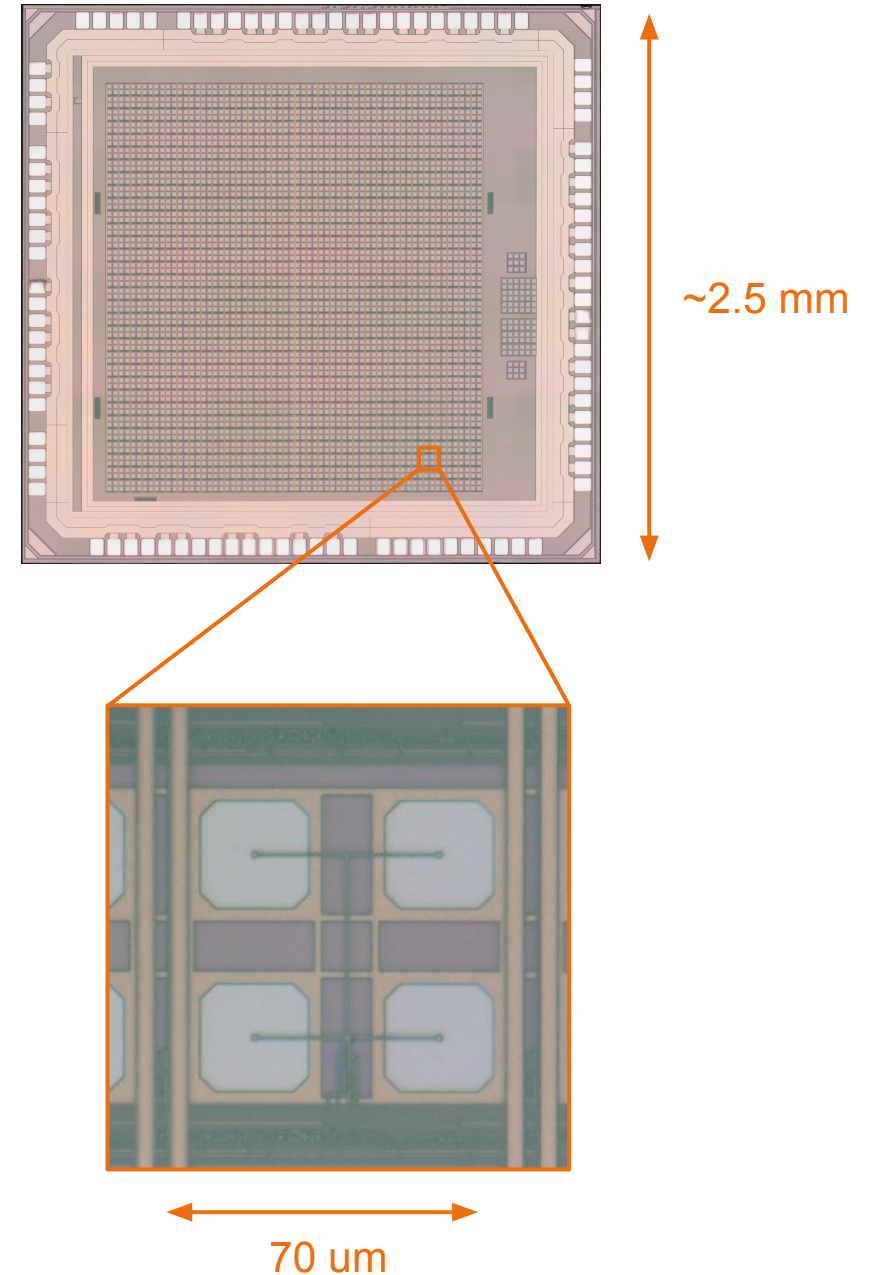
DESY dSiPM reference: [I. Diehl et al. JINST 19 \(2024\) P01020](#)

# DESY digital SiPM prototype

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# DESY digital SiPM prototype

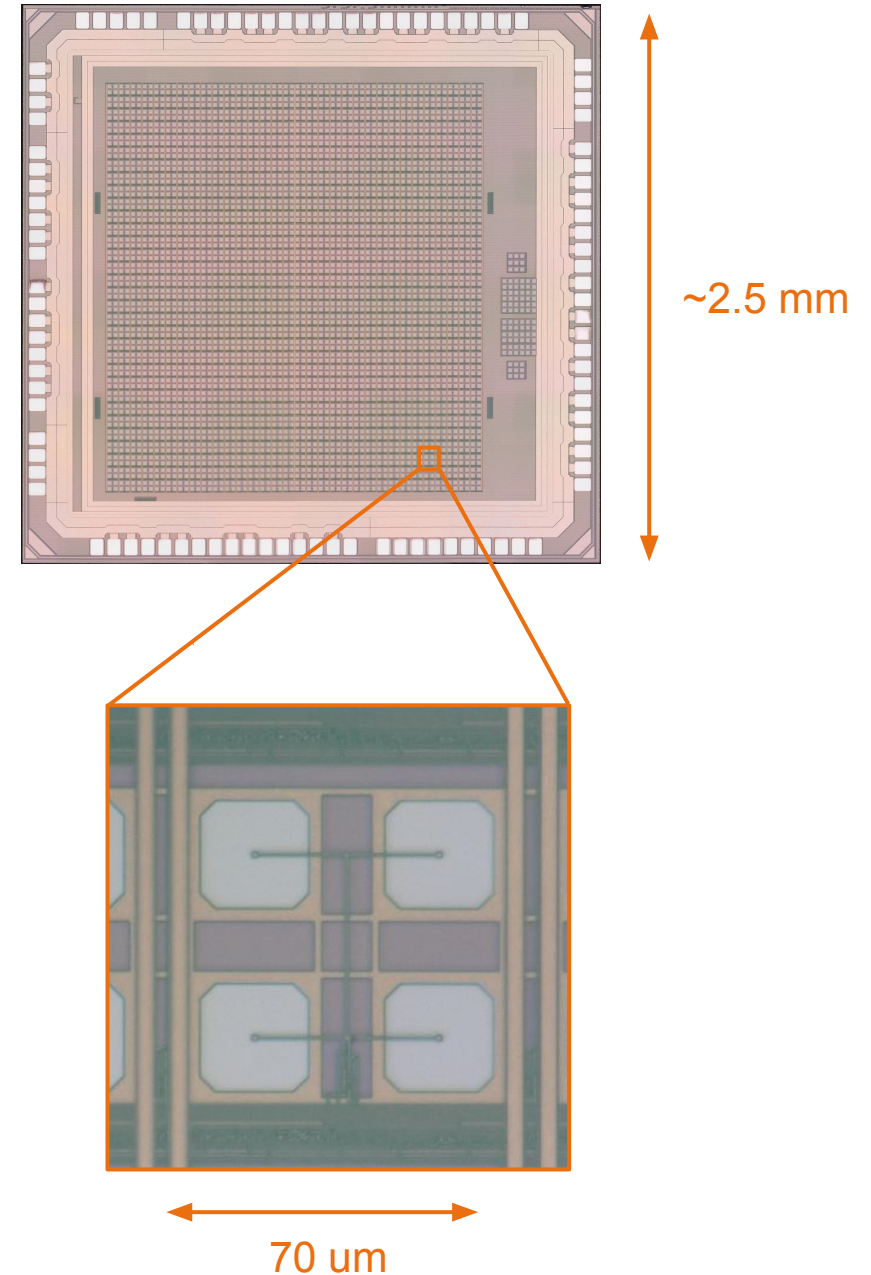
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## Readout:

- Frame-based
- Full binary hitmaps
- Hit pattern recognition
- Pixel masking (with disabling bias on masked pixels)
- Fine hit timestamping via 12-bit TDC (bin size  $\sim 77$  ps)

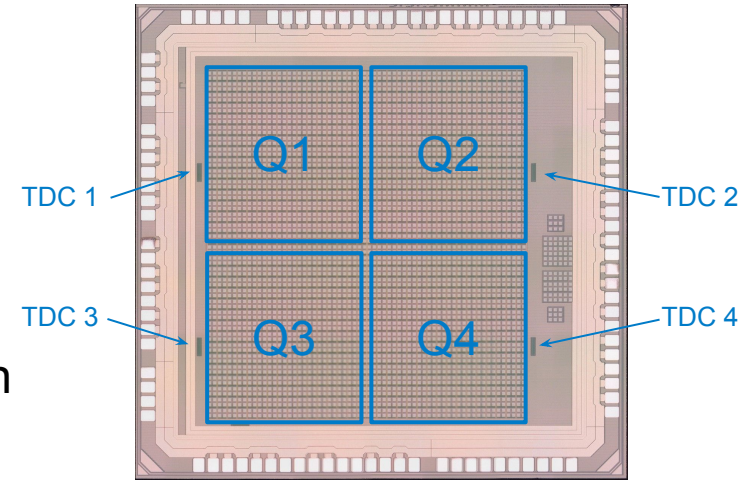


DESY dSiPM reference: [I. Diehl et al. JINST 19 \(2024\) P01020](#)

# How timing works on the chip

## Timestamping mechanism and quadrants

- Each pixel is connected to a shared **time-to-digital converter** (TDC) (located on the **periphery of each quadrant**, 4 total)
- **First pixel to fire** within each frame triggers the TDC of the quadrant it's in
- Thus, up to 4 timestamps are set for each frame (1 per quadrant)

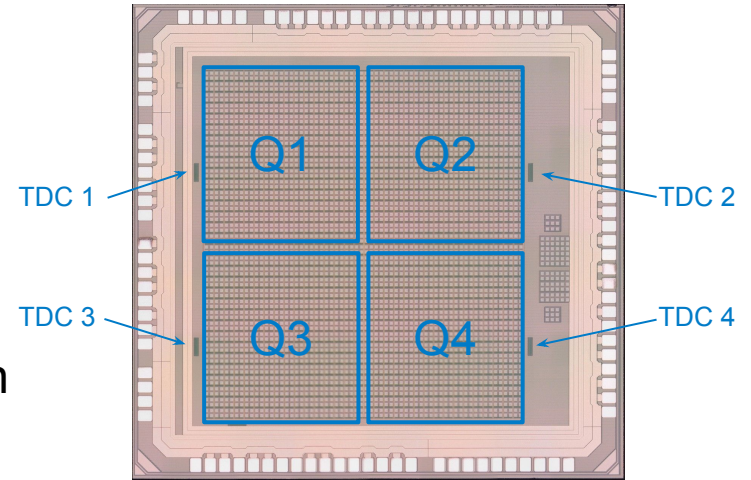


*In the following measurements the masking feature is used to ensure that timestamps only come from a known pixel*

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**Timestamp**  
within a frame (333 ns)

=

**Coarse timestamp**  
bin = 2.45 ns  
7 bits @ 408 MHz chip clock

+

**Fine timestamp**  
bin = 77 ps  
within a chip clock cycle,  
(5-bit delay-locked loop)

*In the following measurements the masking feature is used to ensure that timestamps only come from a known pixel*

manufacturing variation: real bin size = ~95 ps

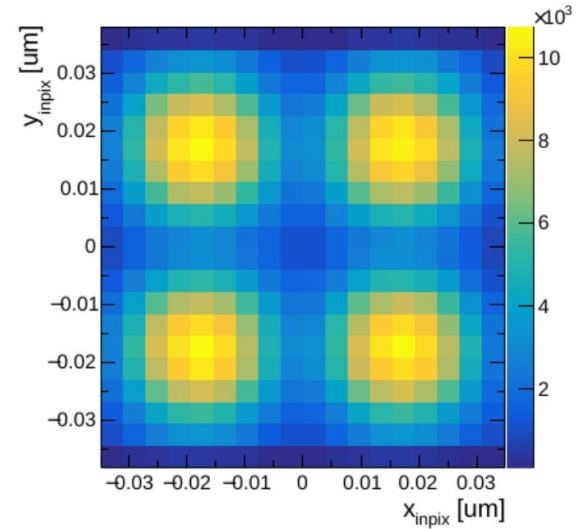
# Timing measurements

# Timing performance @ minimum-ionizing particle detection

A story of peculiar things in the test beam results

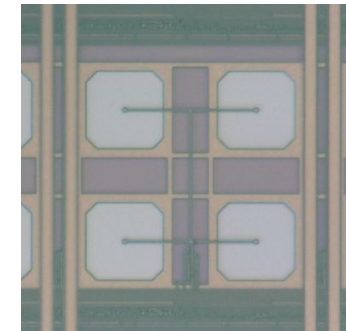
Test-beam campaign @ DESY II:  
chip characterization  
via direct m.i.p. detection (5 GeV  $e^-$ )

In-pixel hitmaps for m.i.p. detection at a testbeam



All events

Pixel layout →



Test beam studies: [F. Feindt et al. NIMA 1064 \(2024\) 169321](#)  
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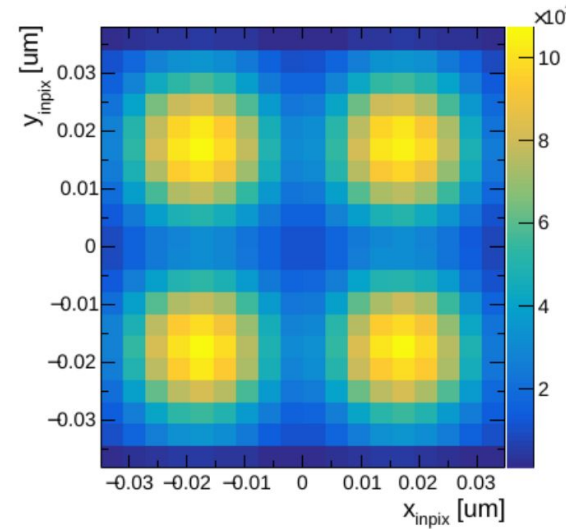
Finding 1:

sub-100 ps is reached, but:

for a fraction of events,

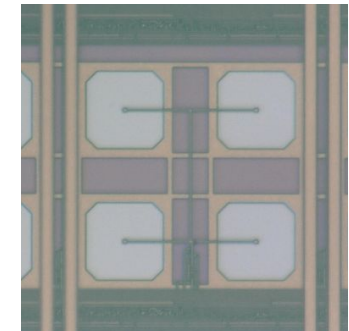
significantly slower response is observed (**few ns**)

In-pixel hitmaps for m.i.p. detection at a testbeam



All events

Pixel layout →



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# Timing performance @ minimum-ionizing particle detection

## A story of peculiar things in the test beam results

### Test-beam campaign @ DESY II:

chip characterization

via direct m.i.p. detection (5 GeV  $e^-$ )

### Finding 1:

**sub-100 ps** is reached, but:

for a fraction of events,

significantly slower response is observed (**few ns**)

### Finding 2:

slow response occurs when a particle track crosses the chip at a **SPAD edge**

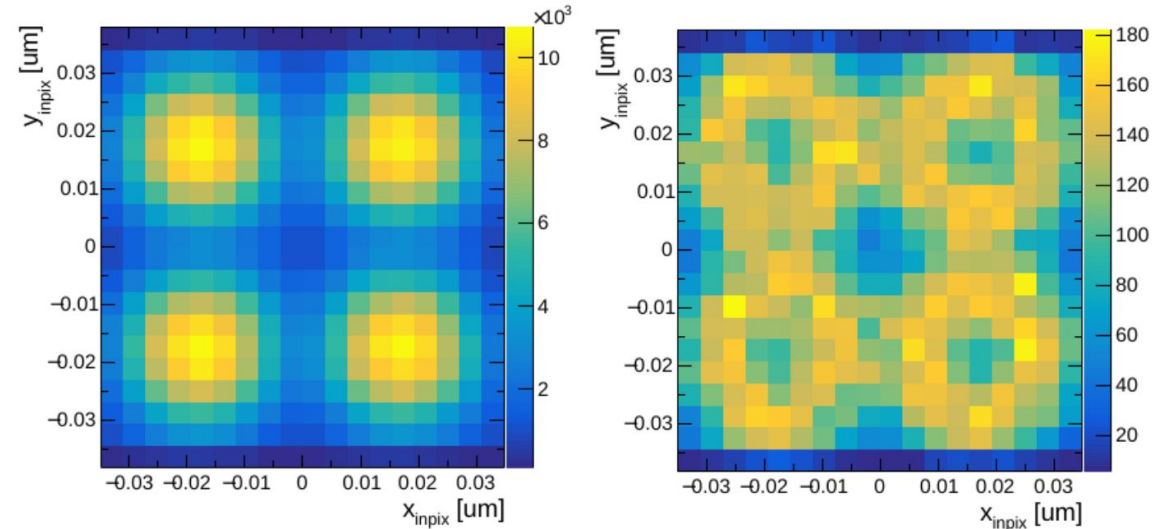
### Hypothesis:

this effect is caused by avalanches being preceded by **drift**

Test beam studies: [F. Feindt et al. NIMA 1064 \(2024\) 169321](#)

[Thesis by S. Lachnit \(2024\)](#)

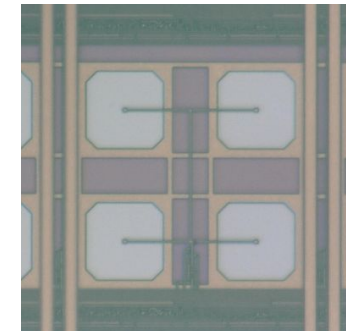
In-pixel hitmaps for m.i.p. detection at a testbeam



All events

Cut on delay >1 ns

Pixel layout →



# Laserbox

## and how to measure timing resolution with it

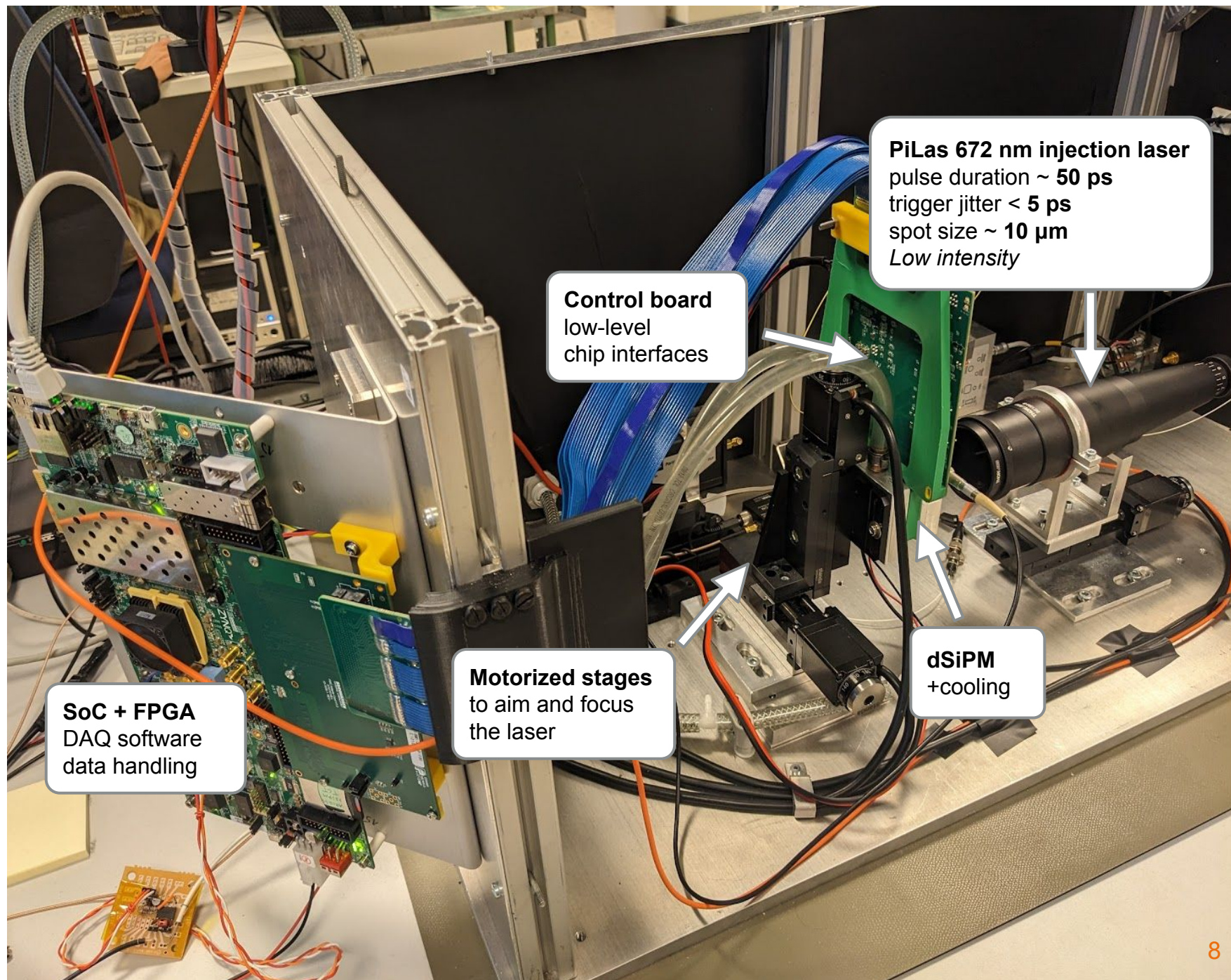
### Pulsed lasers

are great for charge injection:

- micrometer aim precision
- controllable trigger
- high repetition rate
- tunable intensity

### Measurement scheme:

- DAQ+control via Caribou [1]
- laser trigger pulses in sync with readout frames

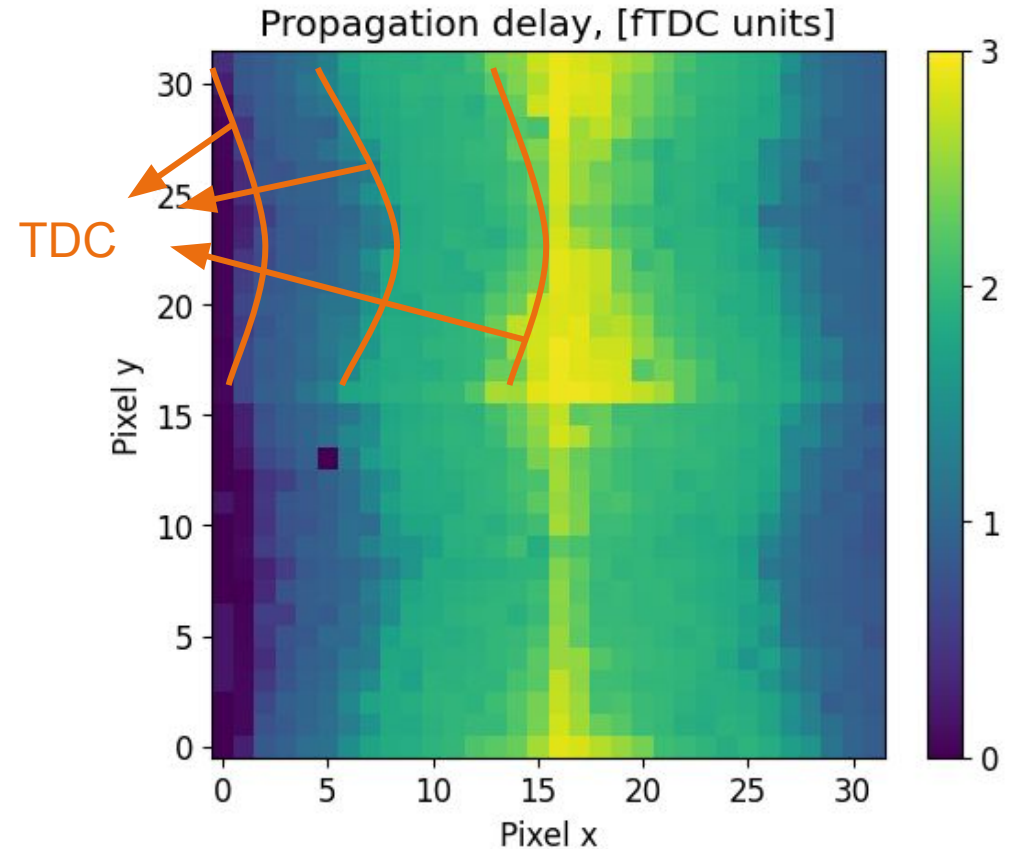
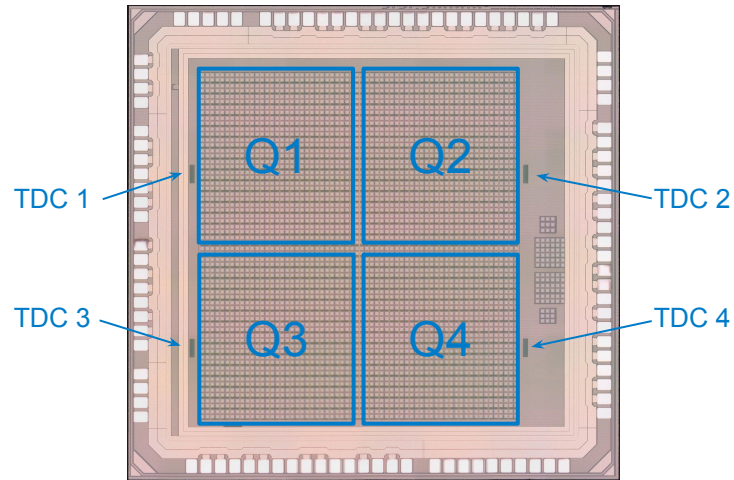


[1] [T. Vanat PoS TWEPP2019 \(2020\) 100](#)



# Propagation delay

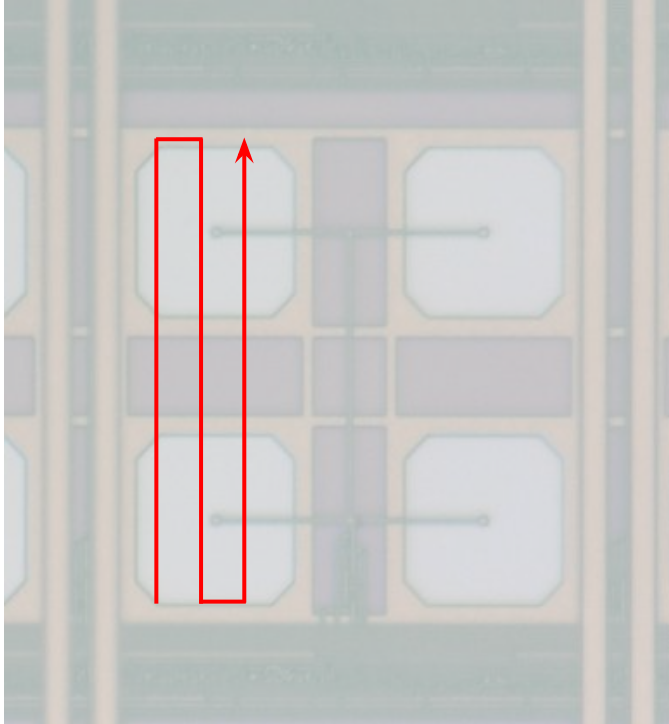
## Corrections for pixel position w.r.t. TDC block



- Additional delay for pixels in the matrix centre, as signals need to **propagate to the periphery**
- This delay can be quantified with a grain of exactly 1 TDC bin
- Results are used as an **lookup table** to **compensate for propagation delay** e.g. in the testbeam

# In-pixel laser characterization

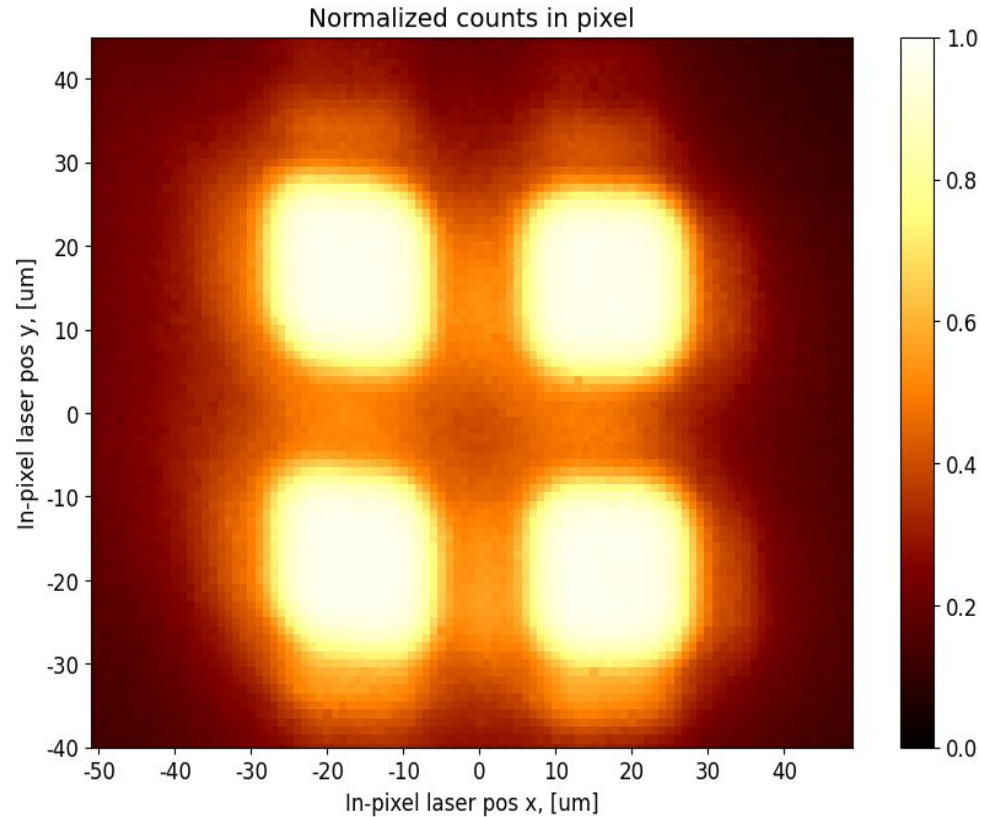
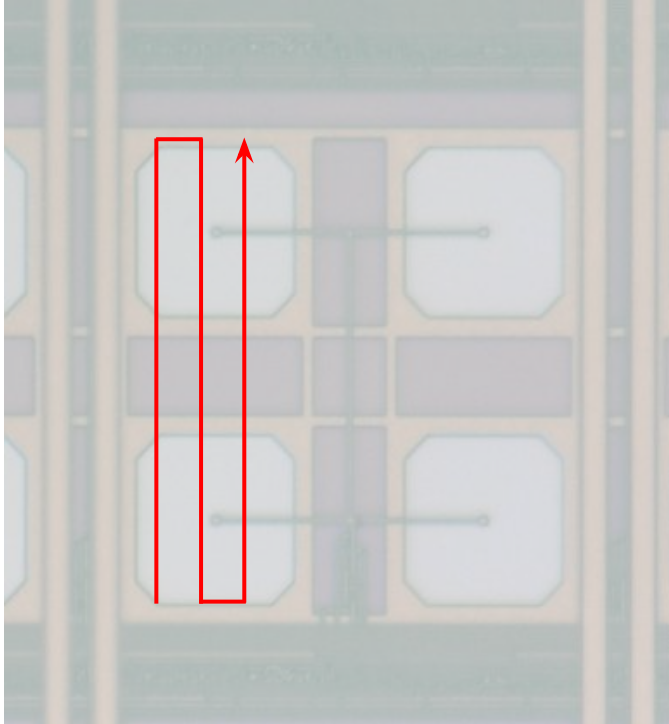
## xy-scan



1. Laser is triggered synchronously with the frame clock → always the same ToA expected
2. Accumulate multiple frames to get the *timing residual distribution*
3. Repeat for all *xy*

# In-pixel laser characterization

## xy-scan



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# In-pixel timing (1)

## Time residual structure

### Main peak (~50 ps width)

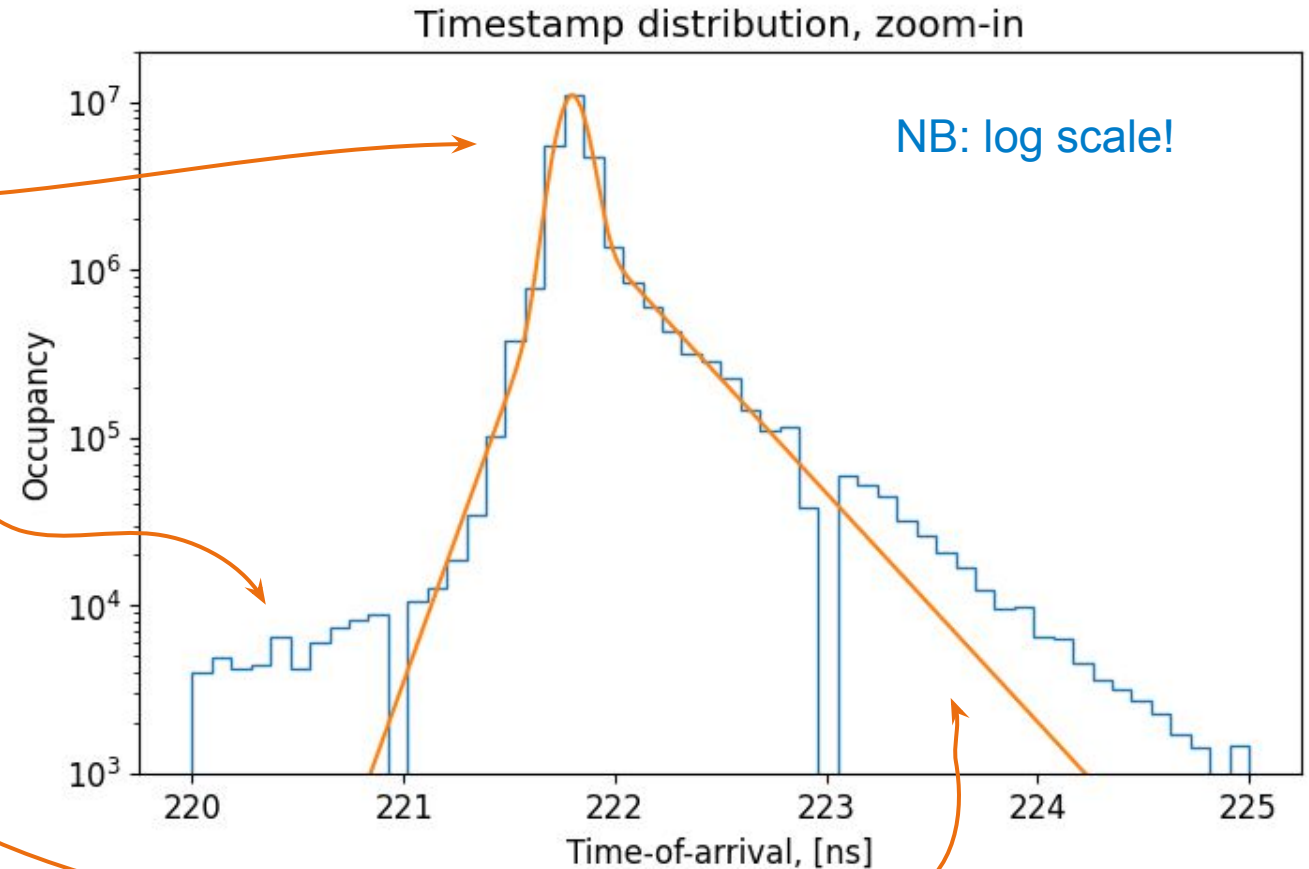
↳ Instant avalanches

### Dark counts

↳ Noise events *before* the laser pulse

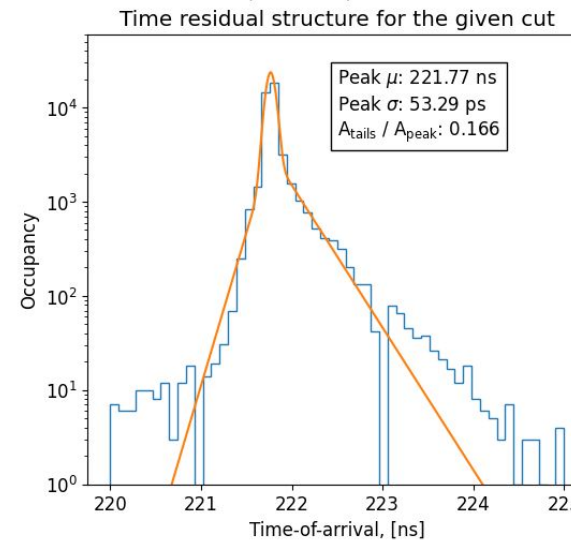
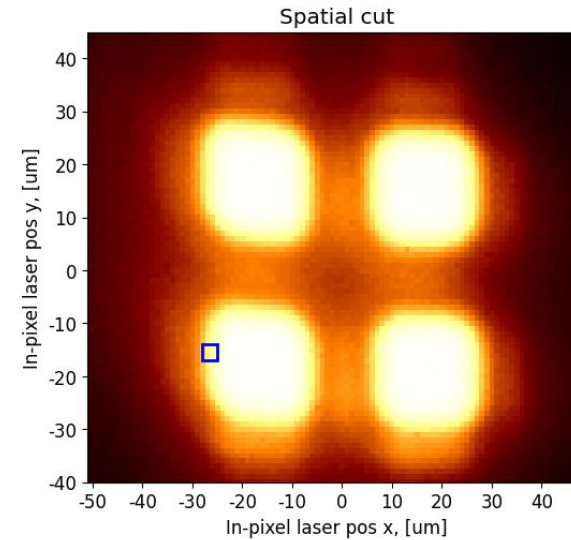
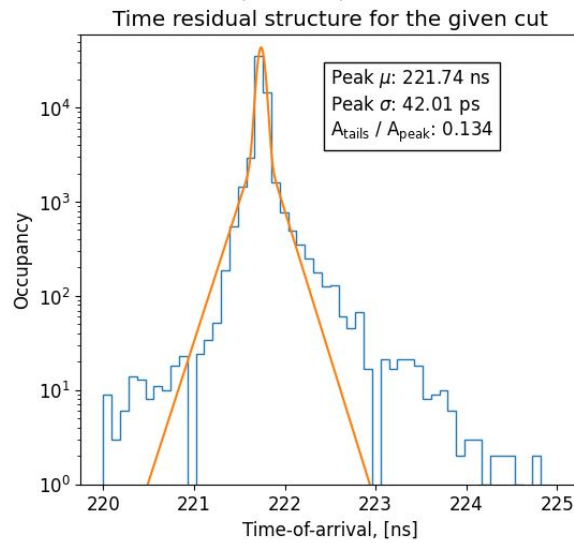
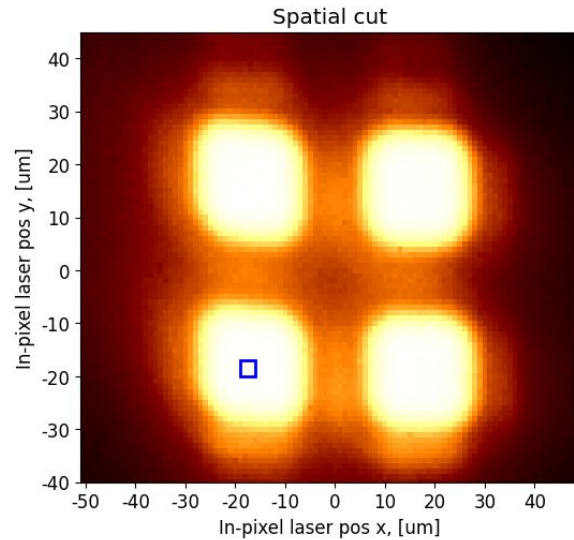
### Tail

↳ Avalanches *preceded* by drift



# In-pixel timing (2)

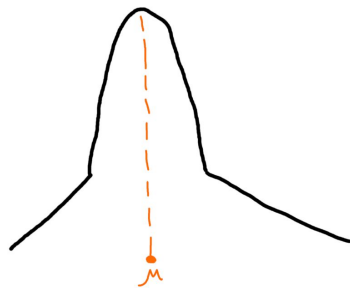
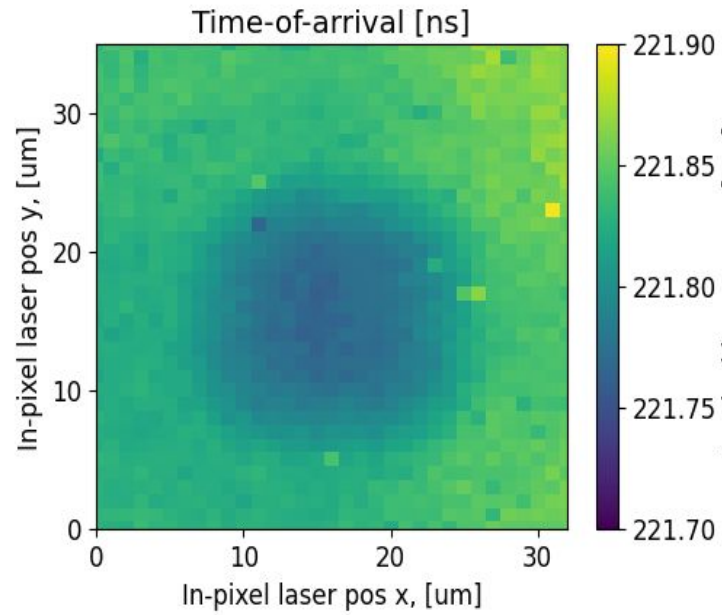
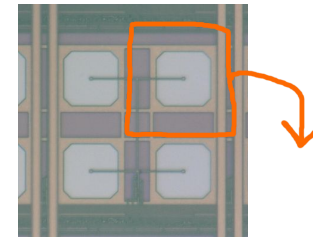
## SPAD center / SPAD edge variations



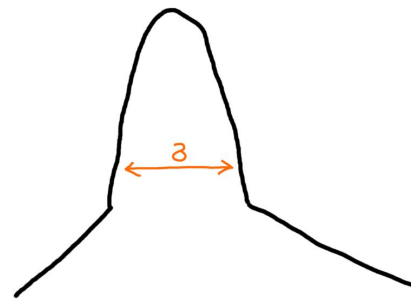
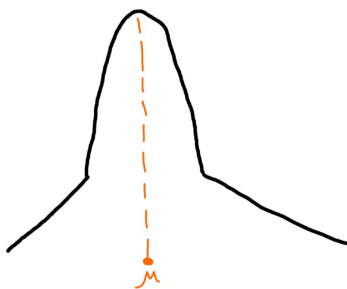
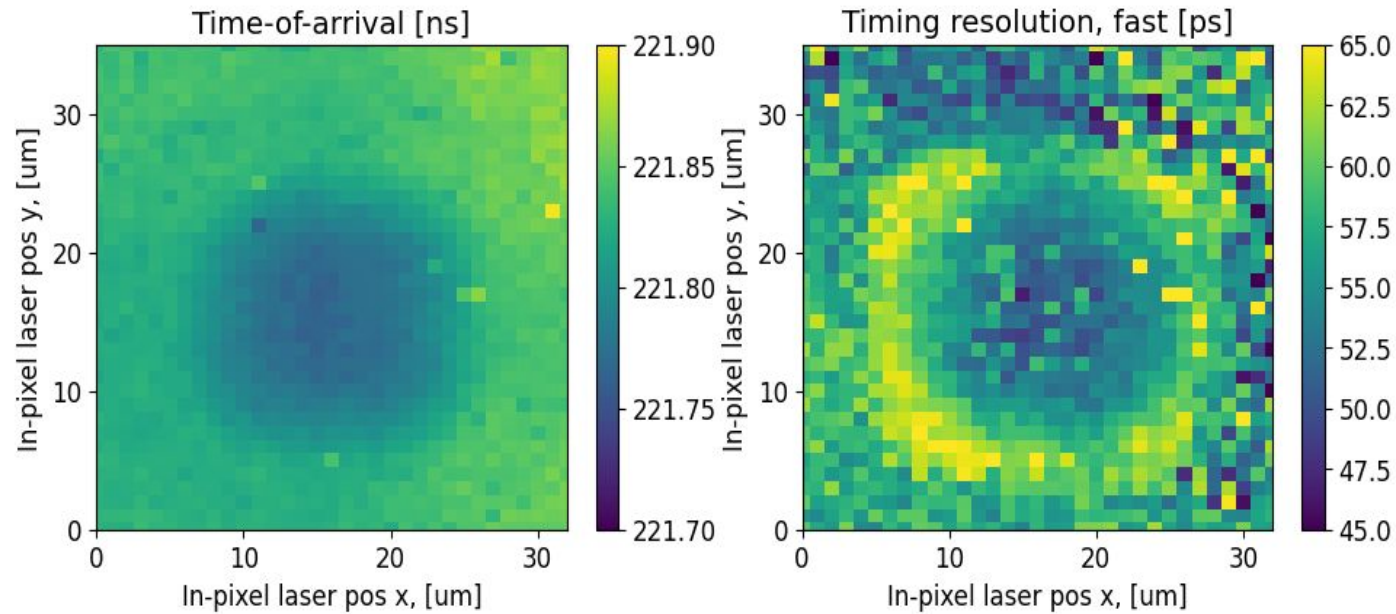
# In-pixel timing (3)

## ToA fit results

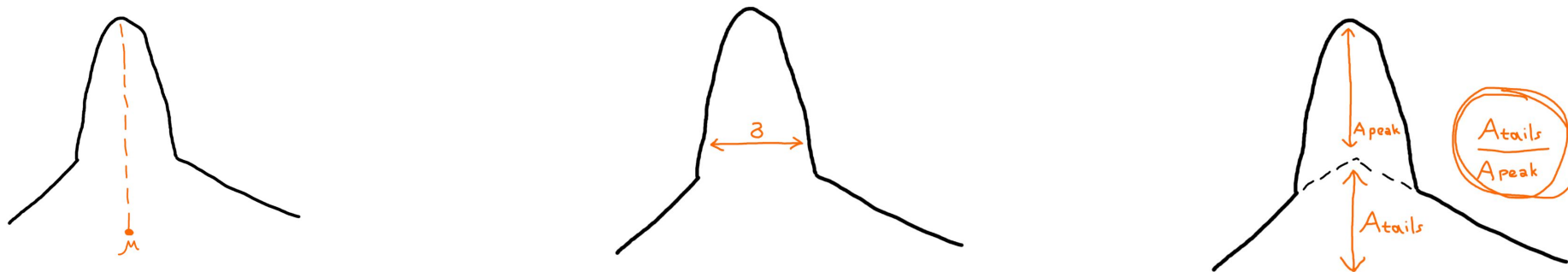
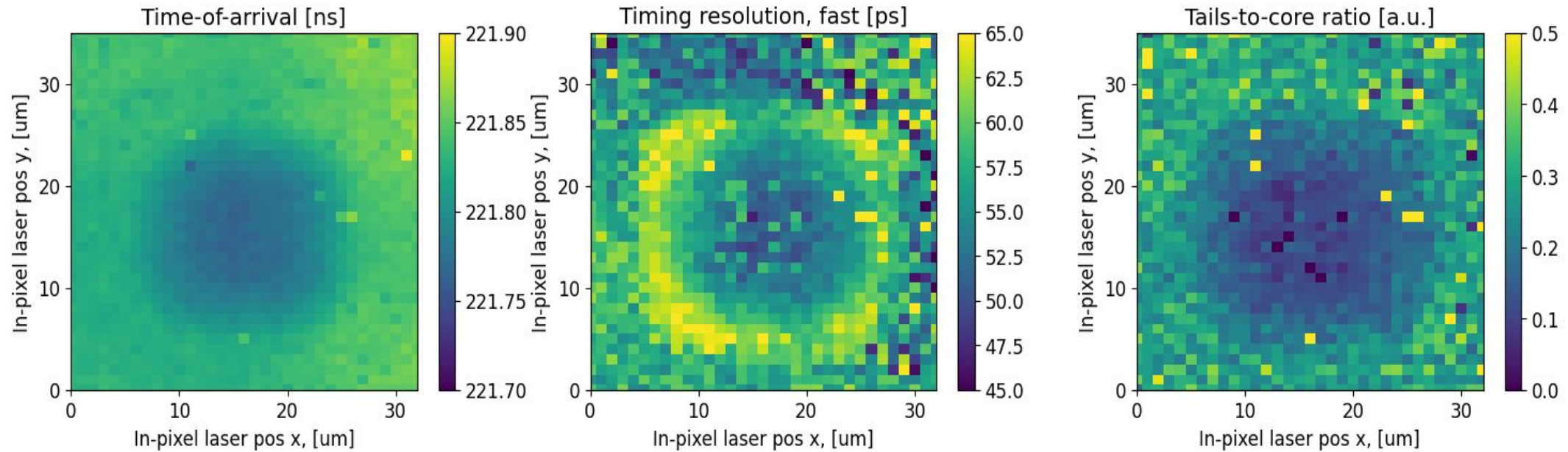
Per-point fits for this region →



- Stable performance in the SPAD centres → instant fast ( $\sim 50$  ps) avalanches
- Fraction of slower ( $\sim$ ns) events → charges drifting to the avalanche region
  - Becomes more significant when the laser is aimed at a SPAD edge



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# Possible applications

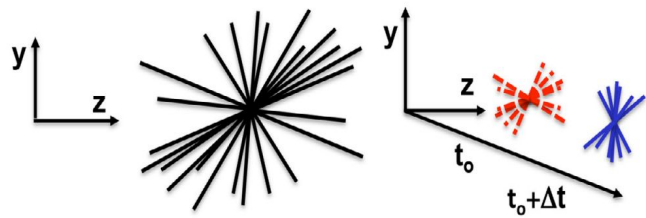
Use cases that require simultaneous spatial and temporal resolution

[1] [H. Sadrozinski et al. \*Rep. Prog. Phys.\* 81 \(2018\) 026101](#)

# Possible applications

Use cases that require simultaneous spatial and temporal resolution

High-energy physics



High-granularity timing,  
e.g. 4D-tracking [1]

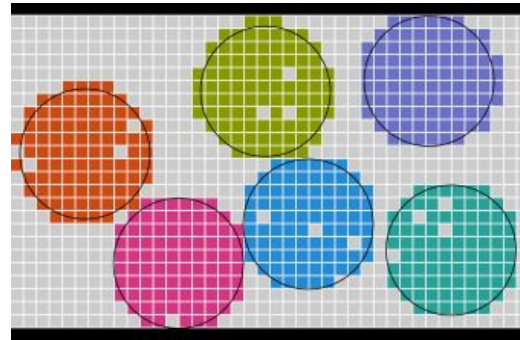
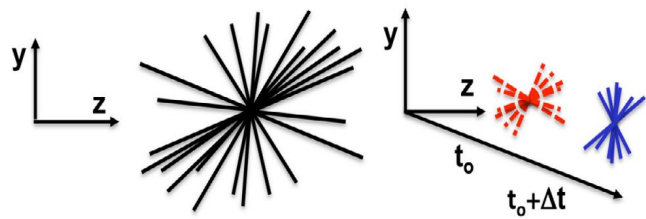
M.I.P. detection

[1] [H. Sadrozinski et al. Rep. Prog. Phys. 81 \(2018\) 026101](#)

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High-granularity timing,  
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Multi-channel fiber readout [2]

M.I.P. detection

Visible (and near-visible) photons

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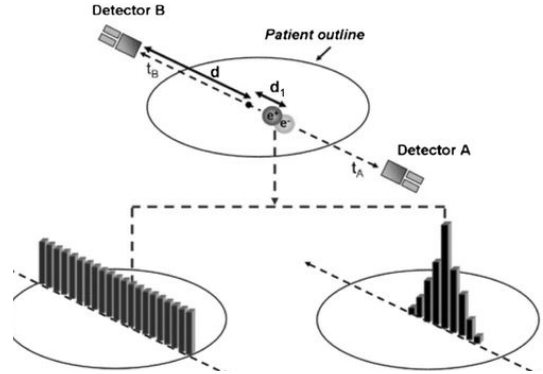
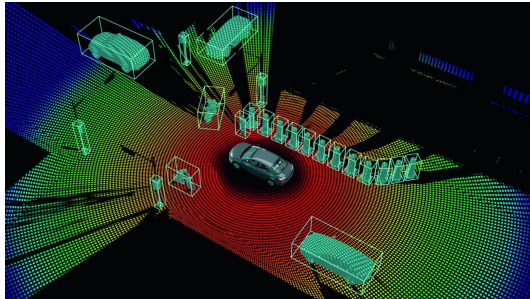
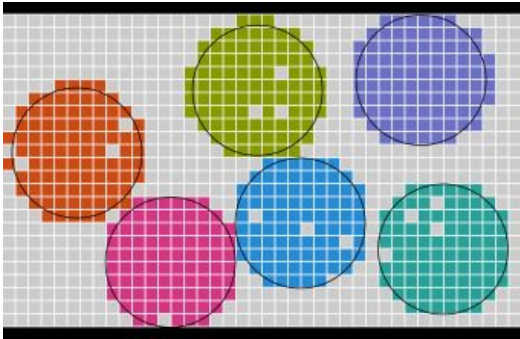
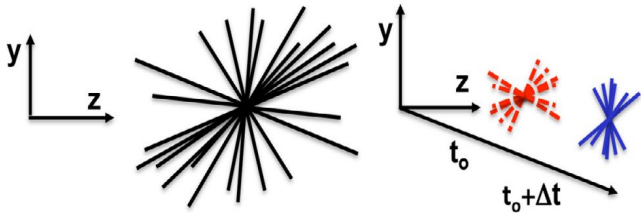
[2] [P. Fischer et al. NIMA 1040 \(2022\) 167033](#)

# Possible applications

Use cases that require simultaneous spatial and temporal resolution

High-energy physics

Industry



High-granularity timing,  
e.g. 4D-tracking [1]

Multi-channel fiber readout [2]

LiDAR

TOF-PET [3]

M.I.P. detection

Visible (and near-visible) photons

Gamma

[1] [H. Sadrozinski et al. Rep. Prog. Phys. 81 \(2018\) 026101](#)  
[2] [P. Fischer et al. NIMA 1040 \(2022\) 167033](#)  
[3] [M. Ullah et al. Nucl Med Mol Imaging 50 \(2016\) 112–122](#)

# Conclusions

**Timing performance** of a **novel dSiPM** prototype studied at a test beam and with a fast injection laser

- Timing resolution is characterized
  - **~50 ps** timing resolution within SPADs
    - This is *total* (sensor + front-end) resolution
    - Timing performance deteriorates at the sensitive area edges
- **Laser** and **test beam** results are **in agreement**
- Design expectations reached\*

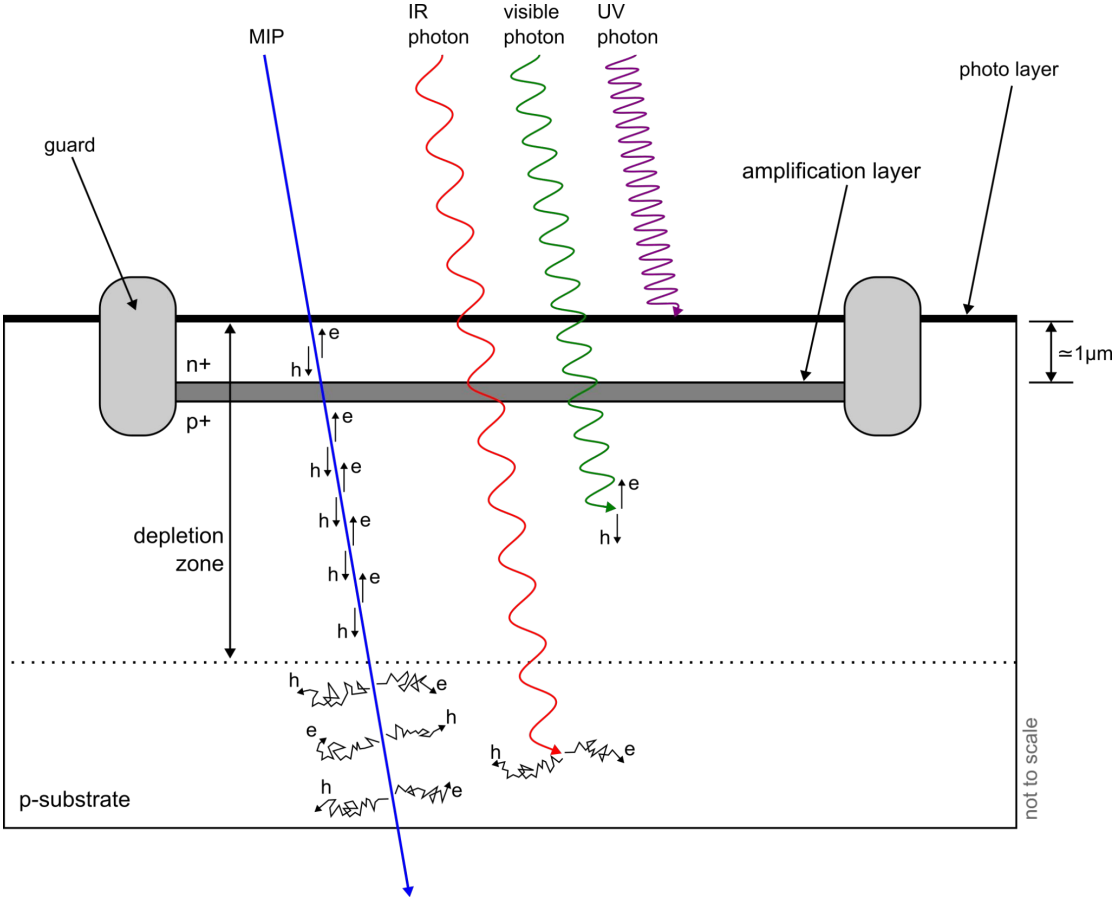
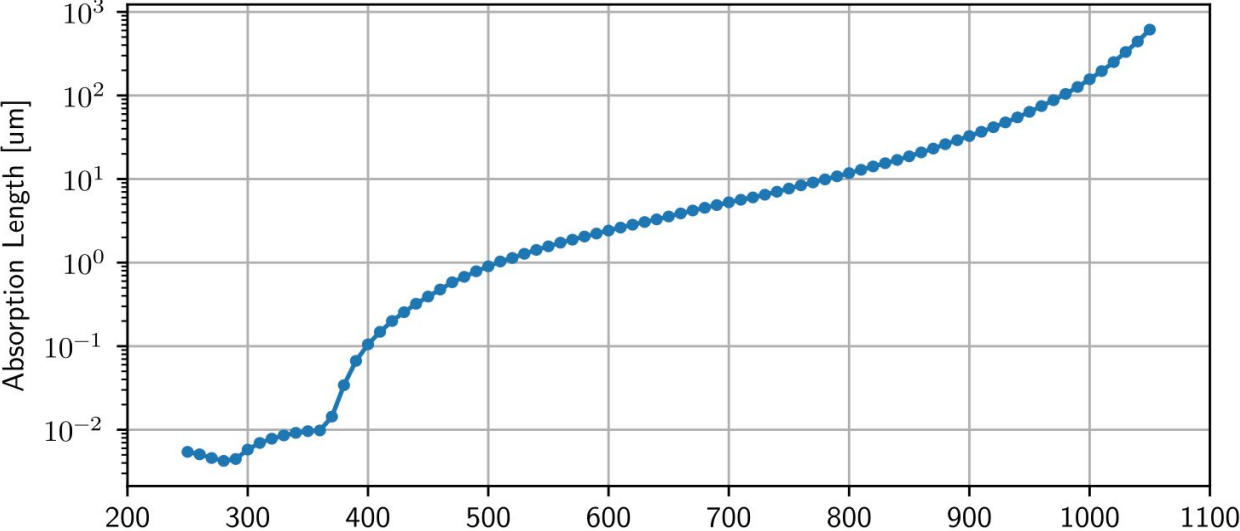
# Thank you!



Scintillator-coupled dSiPM: [G. Vignola et al. NIMA 1069 \(2024\) 169985](#)

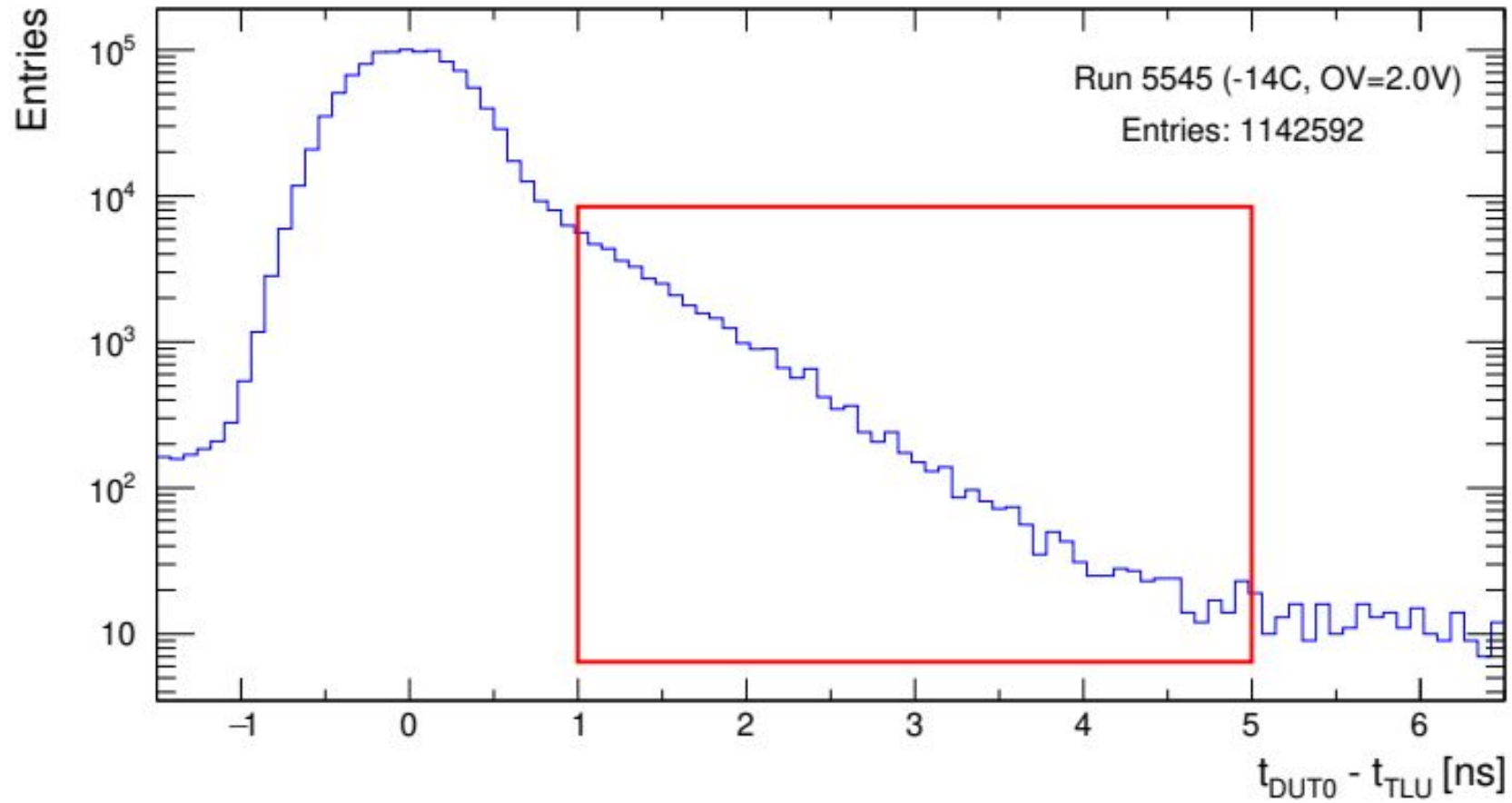
# Backup (1)

## Visible (and near-visible) light in silicon



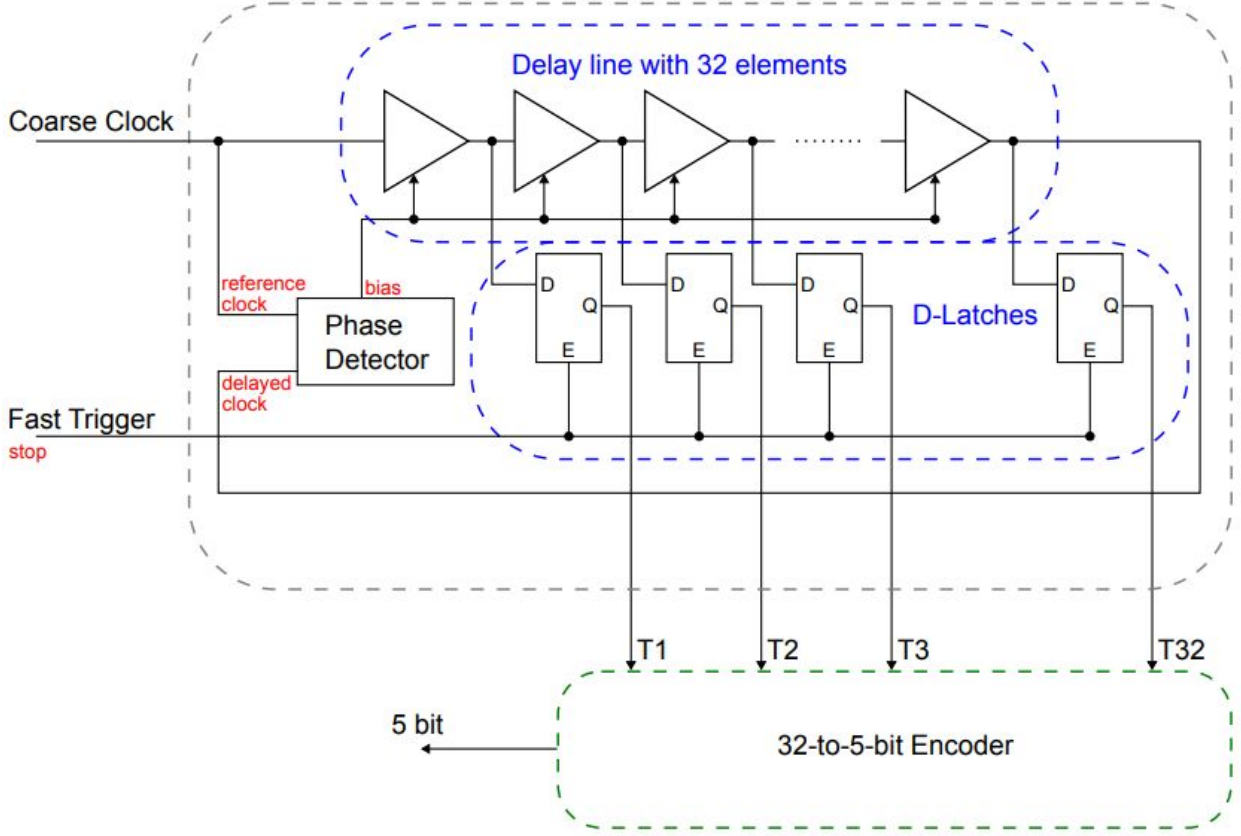
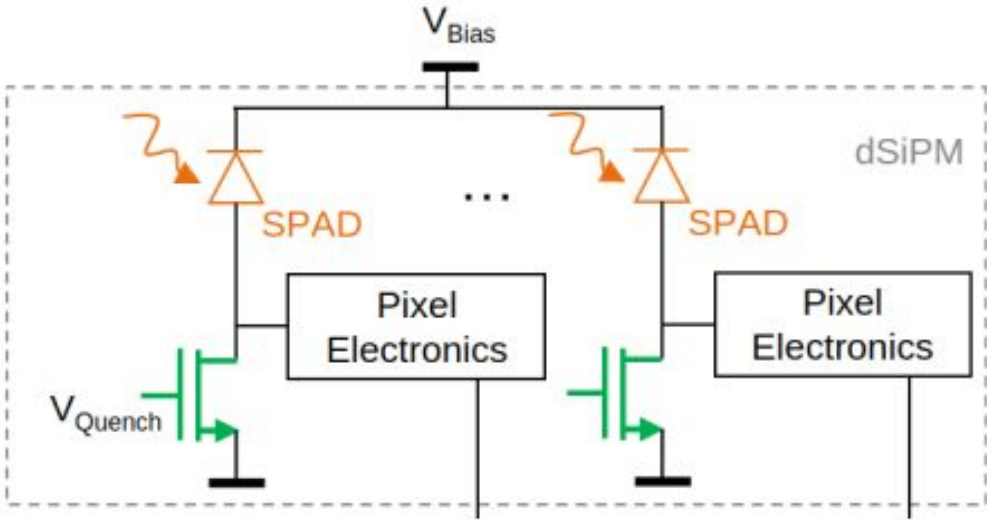
# Backup (3)

## Notes on the testbeam



# Backup (4)

## Pixel schematics





# Backup (5)

## Intrinsic SPAD temporal performance

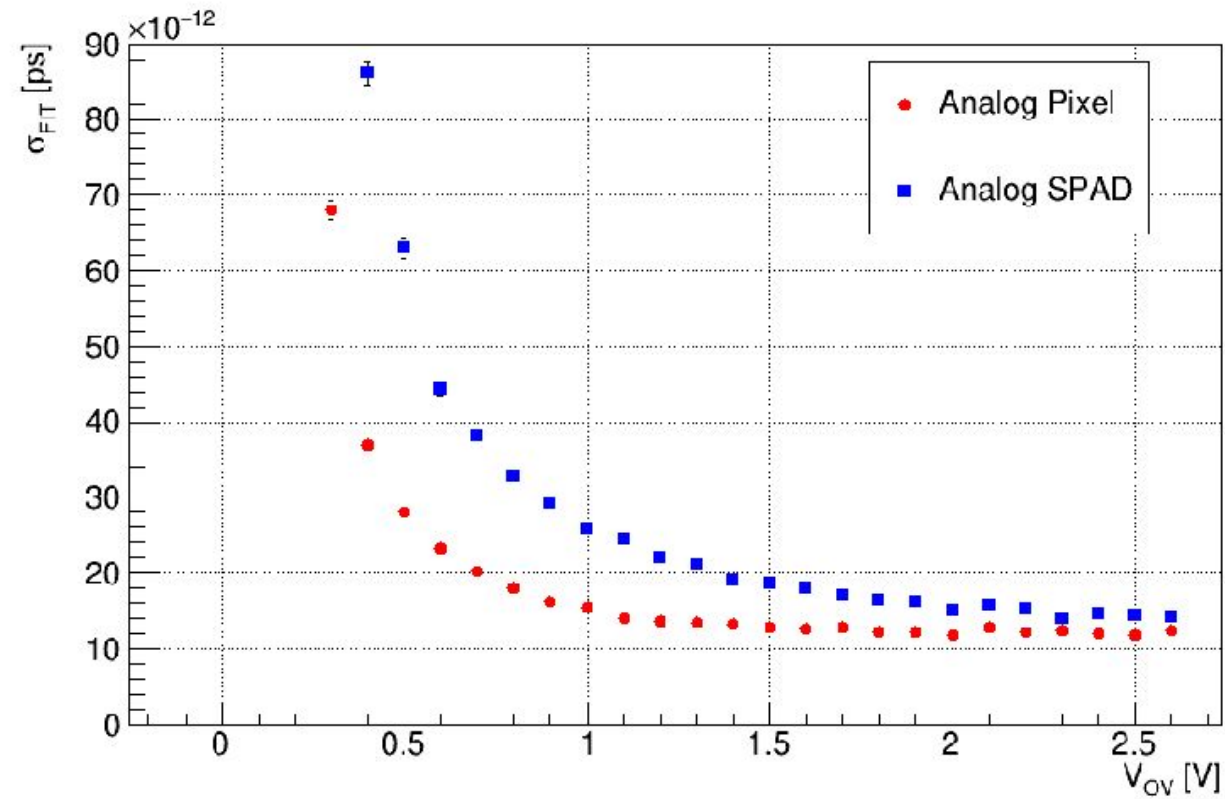


Figure 8.16: Signal TOA as a function of the overvoltage for analogue pixel/SPAD test structures.